



Docket No.: 057454-0994

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Takeshi SATOH, et al.

RESPONSE UNDER 37 C.F.R. 1.116
EXPEDITED PROCEDURE

Application No.: 10/750,870

Filed: January 05, 2004

Customer No.: 20277

Confirmation No.: 3233

Group Art Unit: 1754

Examiner: Edward M. Johnson

Title: POROUS Si3 N4 AND PRODUCING METHOD THEREOF

*OK for entry
for RCE purpose*

AMENDMENT UNDER 37 C.F.R. § 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the Office Action dated October 21, 2005. Please amend the above-identified application as follows.